

<p>FORM HDP-1449 (Based on Form PTO-1449)</p> <p>PATENT AND TRADEMARK OFFICE</p> <p>INFORMATION DISCLOSURE CITATION</p> <p>(Use several sheets if necessary)</p> <p>Sheet 1 of 1</p>	ATTORNEY DOCKET No.	SERIAL No.
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U.S. PATENT DOCUMENTS						
Ref. Desig.	Examiner's Initials	Document Number	Date	Name	Class/ Subclass	(If appropriate) Filing Date
1.		5,521,127	05/28/1996	Hori		
2.		6,191,463	02/20/2001	Mitani et al.		
3.		6,208,002	03/27/2001	Satake et al.		
4.		6,444,533	09/03/2002	Lyding et al.		
5.		2003/168707	09/11/2003	Sakamoto et al.		

FOREIGN PATENT DOCUMENTS							
Ref. Desig.	Examiner's Initials	Document Number	Date	Country	Class/ Subclass	Translation *	
						Yes	No
1.		EP 0 892 424	06/11/1998	Europe		N/A	
2.		EP 1 347 507	07/11/2002	Europe		N/A	

OTHER DOCUMENTS (including Author, Title, Date, Pertinent Pages, etc.)		
Ref. Desig.	Examiner's Initials	
1.		"Interface-trap generation at ultrathin SiO ₂ interfaces during negative-bias temperature aging"; Shigeo Ogawa, Masakazu Shimaya, and Noboru Shiono; J. Appl. Phys 77 (3), 1 February 1995; 1995 American Institute of Physics, pp 1137-1148
2.		"Improved hydrogen free chemical vapor deposition of silicon dioxide"; Yasutaka Uchida, Kohshi Taguchi, and Masakiyo Matsumura; Journal of Non-Crystalline Solids 354 (1999) 11-16; 1999 Elsevier Science B. V.
3.		"Effect of N ₂ O/SiH ₄ ratio on the properties of low-temperature silicon oxide films from remote plasma chemical vapour deposition"; Youg-Bae Park, Jin-Kyu Kang, Shi-Woo Rhee; Thin Solid Films 280 (1996) 43-50; Elsevier Science S.A.

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Examiner: /Edward Wojciechowicz/	Date Considered: 08/04/2008
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ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /EW/